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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	10/558,727-Conf. #7063
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Filing Date	November 28, 2005
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First Named Inventor	Hiroyuki Kanda
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Art Unit	1794
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Examiner Name	T. M. Speer
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Attorney Docket Number	20241/0203623-US0
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Sheet	1	of	2
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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ³
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	EP-1011040	06-21-2000	NISSHA PRINTING		

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Sheet	2	of	2	Attorney Docket Number	20241/0203623-US0

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	Y. SHIGESATO ET AL., "Early Stages of ITO Deposition on Glass or Polymer Substrates", Vacuum, vol. 59, November 2000, pages 614-621	
	CB	M. MARTINO ET AL., "Characterization of Thin Indium Tin Oxide Films Deposited by Pulsed XeCl Laser Ablation" Journal of Physics D (Applied Physics), vol. 34, no. 17, September 7, 2201, pages 2606-2609.	
	CC	T. MINAMI ET AL., "Physics of Very Thin ITO Conducting Films With High Transparency Prepared by DC Magnetron Sputtering", December 1, 1995, Thin Solid Films, pgs. 37-42.	
	CD	M. GIRTAN ET AL., "On the Physical Properties of Indium Oxide Thin Films Deposited by Pyrosol in Comparison with Films Deposited by Pneumatic Spray Pyrolysis", March 3, 2003, Thin Solid Films, pgs. 406-410.	

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